

Philippe De Rouffignac

List of Publications by Year in descending order

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4
papers

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citations

1937685

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2272923

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521
citing authors

#	ARTICLE	IF	CITATIONS
1	Atomic Layer Deposition of Y ₂ O ₃ Thin Films from Yttrium Tris(N,N-diisopropylacetamidate) and Water. <i>Chemistry of Materials</i> , 2005, 17, 4808-4814.	6.7	134
2	Atomic layer deposition of lanthanum aluminum oxide nano-laminates for electrical applications. <i>Applied Physics Letters</i> , 2004, 84, 3957-3959.	3.3	78
3	Highly conformal atomic layer deposition of tantalum oxide using alkylamide precursors. <i>Thin Solid Films</i> , 2003, 443, 1-4.	1.8	64
4	ALD of Scandium Oxide from Scandium Tris(N,N-diisopropylacetamidate) and Water. <i>Electrochemical and Solid-State Letters</i> , 2006, 9, F45.	2.2	36